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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2811**

PATENT

Customer No. 22,852

Attorney Docket No. **04329.2344-02**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Kyoichi SUGURO et al.)	Group Art Unit: 2811
)	
Application No.: 10/623,732)	Examiner: Steven Ho Yin Loke
)	
Filed: July 22, 2003)	
)	Confirmation No.: 6071
For: SEMICONDUCTOR DEVICE HAVING)	
AN ELEMENT ISOLATING)	Mail Stop AF
INSULATION FILM)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Office Action mailed December 1, 2004, the period for response to which extends to March 1, 2005, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Specification are set forth in this paper beginning on page 2.

Amendments to the Claims are set forth in the listing of claims beginning on page 4.

Remarks/Arguments follow the Amendment sections of this paper, beginning on page 9.